

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Jerome Jackson, Jr.
KAZUYA NOTSU, ET AL.)	
	:	Group Art Unit: 2815
Application No.: 10/540,261)	
	:	Confirmation No. 1426
Filed: June 23, 2005)	
	:	
For: SEMICONDUCTOR MEMBER,)	
MANUFACTURING METHOD	:	
THEREOF, AND SEMICONDUCTOR)	
DEVICE	:	May 11, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR EXAMINER TO INITIAL
PTO FORM 1449 SUBMITTED JANUARY 23, 2007

Sir:

The Examiner is respectfully requested to consider and initial the above-referred-to Form PTO 1449 (copy attached), which was attached to an Information Disclosure Statement filed on January 23, 2007, and return that form to the undersigned, indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

/John A. Krause/

John A. Krause

Attorney for Applicants

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